L	Hits	Search Text	DB	Time stamp
Number			USPAT	2003/05/29
1	4	313/\$.ccls. and organic and encapsulat\$ and	USPAT	07:47
		moisture and williams.xa.	USPAT	2003/05/29
2	82	313/\$.ccls. and organic and encapsulat\$ and	USPAI	07:48
		moisture		2003/05/29
3	11	313/\$.ccls. and organic and encapsulat\$ and	USPAT	
		moisture and anode and cathode and laminat\$		08:32
4	37	313/\$.ccls. and organic and encapsulat\$ and	USPAT	2003/05/29
_		moisture and anode and cathode		08:37
5	1	("5952778").PN.	USPAT	2003/05/29
<b>3</b>	-	( 0002:00 ):		08:40
6	20	("4356429"   "4539507"   "4983310"	USPAT	2003/05/29
•	20	"5124204"   "5169547"   "5189549"		08:37
		"5214306"   "5247190"   "5296724"		
		"5328580"   "5337374"   "5362410"		
		"5373175"   "5391756"   "5408109"		
		"5449926"   "5593788"   "5757126"		
		· ·		
		"5771562"   "5811177").PN.	USPAT	2003/05/29
7	11	5952778.URPN.	USFAI	08:38
	_	W-000000   W-404004W   W-400405W	USPAT	2003/05/29
8	6	("5036249"   "5124204"   "5189405"	USPAI	08:39
		"5771562"   "5811177"   "5952778").PN.	HEDAT	2003/05/29
9	8	6198217.URPN.	USPAT	08:39
10	1065	313/504	USPAT	2003/05/29
İ				08:40
11	1437	((313/504) or (313/506) or (313/512)).CCLS.	USPAT	2003/05/29
				09:06
12	5	("5124204"   "6111357"   "6210815"	USPAT	2003/05/29
		"6268071"   "6284342"). <b>PN</b> .		08:45
13	3	("4769292"   "5122711"   "5792557").PN.	USPAT	2003/05/29
				08:51
14	1	("5952778").PN.	USPAT	2003/05/29
				09:29
15	11	5952778.URPN.	USPAT	2003/05/29
				09:06
16	0	6570325.pn. and cathode and anode	USPAT	2003/05/29
				09:30
17	1	6570325.pn. and electrode	USPAT	2003/05/29
• •	•			09:45
40	141	(passivation adj (film or layer)) and	USPAT	2003/05/29
18	171	313/\$.ccls.		09:46
40	24	(passivation adj (film or layer) same (Al or	USPAT	2003/05/29
19	24	aluminum)) and 313/\$.ccls.		09:52
20	84		USPAT	2003/05/29
20	04	gold or indium or In)) and 313/\$.ccls.		09:57
	4.4		USPAT	2003/05/29
21	19		00.7.	09:59
	_	gold or indium)) and 313/\$.ccls.	USPAT	2003/05/29
22	6		USFAI	10:01
		gold)) and 313/\$.ccls.		10.01
23	957	(passivation adj (film or layer) same (Au of	USPAT	2003/05/29

		The state of the s	USPAT	2003/05/29
24	957	(passivation adj (film or layer) same (Au or gold))	USPAI	12:01
	404	silicon same nitride same plasma same CVD	USPAT	2003/05/29
25	161	same silane same nitrogen		12:13
	1	(silicon same nitride same plasma same CVD	USPAT	2003/05/29
26		same silane same nitrogen) and		12:03
		electroluminescence		
~~	0	(silicon same nitride same plasma same CVD	USPAT	2003/05/29
27	· ·	same silane same nitrogen) and 445/\$.ccls.		12:06
	498	(shadow adj mask) and 445/\$.ccls.	USPAT	2003/05/29
28	790	(Silduoti daj illasti, dila 1101)		12:07
30	36	williams.xa. and day.xp. and cathode and	USPAT	2003/05/29
30	50	313/\$.ccis.		12:20
31	120	williams.xa. and patel.xp. and cathode and	USPAT	2003/05/29
31	.20	313/\$.ccls.		12:20
32	32	williams.xa. and patel.xp. and cathode and	USPAT	2003/05/29
32	<b>-</b>	313/\$.ccls. and grid		12:26
33	697	313/407	USPAT	2003/05/29
JJ				12:26
34	432	(313/407).CCLS.	USPAT	2003/05/29
J-4	102	(6.6, 16.7)		12:28
35	89	(313/407).CCLS.	US-PGPUB	2003/05/29
33		(0.0, 10.1)		12:26
36	o	313/407.ccis. and (busbar same glass same	USPAT	2003/05/29
30		rigid)		12:29
37	3	313/407.ccls. and (busbar same glass)	USPAT	2003/05/29
<b>J</b> .				12:30
38	0	313/407.ccls. and (busbar same glass)	USOCR	2003/05/29
				12:30
39	0	(shadow adj mask) and (busbar same glass)	EPO; JPO;	2003/05/29
			DERWENT;	12:31
			IBM_TDB	
40	71	busbar same glass	USOCR	2003/05/29
				12:31
41	0	(busbar same glass) and mask and CRT	USOCR	2003/05/29
				12:31
42	6	(busbar same glass) and mask	USOCR	2003/05/29
	ŀ			12:33
43	432	(313/407).CCLS.	USPAT	2003/05/29
				12:35
44	1	("6175185").PN.	USPAT	2003/05/29
				12:38
45	0	(shadow adj mask) and (hole same buidge)	USPAT	2003/05/29
				12:42 2003/05/29
46	0	(shadow adj mask) and (buldge)	USPAT	
	1		HCDAT	12:42 2003/05/29
47	2	("5635320"   "5856725"). <b>PN</b> .	USPAT	12:39
			HEDAT	2003/05/29
48	53	(shadow adj mask) and (bulge)	USPAT	12:42
			HEDAT	2003/05/29
49	7	(shadow adj mask) and (hole same bulge)	USPAT	12:43
			HERAT	2003/05/29
50	2	(shadow adj mask) and (slot same bulge)	USPAT	
50	2	(snadow adj mask) and (slot same bulge)	JULAI	12:43

29	102	silicon same nitride same (plasma adj CVD)	USPAT	2003/05/29	l	
		same silane same nitrogen		12:45	ı	
	l		i same siiane same illuvytii			,